ABSTRACT

1	A smaller electrode layer of an upper electrode is formed on a surface
2	of a free magnetic layer. A domain controlling film of an insulating material is formed
3	adjacent to the smaller electrode layer on the surface of the free magnetic layer.
4	Magnetization of the free magnetic layer is oriented in a single direction based on
5	magnetic exchange coupling between the domain controlling film and the free magnetic
6	layer. An electric connection is established between the free magnetic layer and the
7	upper electrode only through the smaller electrode layer. The path of a sensing current
8	can be reduced in the free and a pinned magnetic layer. A higher sensitivity can thus be
9	obtained in the CPP structure magnetoresistive element. Effective magnetic core width
10	can also be reduced in the CPP structure magnetoresistive element.